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CONFIRMATION NO. 6424

SERIAL NUMBER 10/531,208	FILING OR 371(c) DATE 04/14/2005 RULE	CLASS 430	GROUP ART UNIT 1756	ATTORNEY DOCKET NO. 28955.1048
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APPLICANTS

Mitsuru Ueda, Tokyo, JAPAN;
 Hirotoshi Ishii, Chiba, JAPAN;

** CONTINUING DATA *****

This application is a 371 of PCT/JP03/11137 09/01/2003

** FOREIGN APPLICATIONS *****

JAPAN 2002300144 10/15/2002
 JAPAN 2003112458 04/17/2003

Foreign Priority claimed	<input type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY JAPAN	SHEETS DRAWING	TOTAL CLAIMS 20	INDEPENDENT CLAIMS 3
35 USC 119 (a-d) conditions met	<input type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> Met after Allowance				

ADDRESS

27890

TITLE

Photoresist base material, method for purification thereof, and photoresist compositions

FILING FEE RECEIVED 900	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
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Verified and Acknowledged	Examiner's Signature Initials

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